



Attorney Docket # 5300-23

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

John A ROUSE et al.

Serial No.: 09/994,563

Filed: November 27, 2001

For: Reduction Of Aberrations Produced By Wien
Filter In A Scanning Electron Microscope And
The Like

Examiner: El Shammaa, M.
Group Art: 2881

I hereby certify that this correspondence is being
deposited with the United States Postal Service with
sufficient postage as first class mail in an envelope
addressed to: Commissioner for Patents, P.O. Box
1450, Arlington, VA 22313-1450, on
February 3, 2004
(Date of Deposit)

Thomas Langer

Name of applicant, assignee or Registered Representative

Signature

February 3, 2004

Date of Signature

Mail Stop **ISSUE FEE**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

COMMUNICATION FORWARDING FORMAL DRAWINGS

S I R:

Responsive to the Notice Of Allowance dated November 6, 2003, enclosed are two sheets
of formal drawings (Figs. 1 to 2) as requested.

In the event that any fees or charges are deemed necessary in connection with the
application at the present time, the same may be charged to our Deposit Account No. 03-2412.

Respectfully submitted,
COHEN, PONTANI, LIEBERMAN & PAVANE

By

Thomas Langer, Reg. No. 27,264
551 Fifth Avenue
New York, New York 10176
(212) 687-2770

Dated: February 3, 2004